

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/699,869	CHEN ET AL.
	Examiner	Art Unit
	Helen C. Kwok	2856

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
73	504.13	2/11/2005	HK
73	504.02	2/11/2005	HK